| Ref<br># | Hits | Search Query   | DBs    | Default  | Plurals | Time Stamp       |
|----------|------|--|--------|----------|---------|------------------|
|          |      | ("E7E3E66") DN   | LICDAT | Operator | OFF     | 2005/04/26 12:07 |
| L1       | 1    | ("5753566").PN.  | USPAT  | OR       | OFF     | 2005/04/26 12:07 |
| L2       | 1    | ("6024828").PN.  | USPAT  | OR       | OFF     | 2005/04/26 12:07 |
| L3       | . 1  | ("6482716").PN.  | USPAT  | OR       | OFF     | 2005/04/26 12:08 |
| L4       | 1    | ("6630397").PN.  | USPAT  | OR       | OFF     | 2005/04/26 12:08 |
| L5       | 1    | 4 and (chilled or water or helium or surface or openings or plurality or spin or on or material or temperature or "50" or glass or dielectric or etch or etching or plasma or expose or fluid or gas or liquid or region or sparse or dense or trench or photo or resist or coating or cooled or cooling or wafer) | USPAT  | OR       | ON      | 2005/04/26 12:15 |
| L6       |      | 3 and (chilled or water or helium or surface or openings or plurality or spin or on or material or temperature or "50" or glass or dielectric or etch or etching or plasma or expose or fluid or gas or liquid or region or sparse or dense or trench or photo or resist or coating or cooled or cooling or wafer) | USPAT  | OR       | ON      | 2005/04/26 12:18 |
| L7       | 1    | 2 and (chilled or water or helium or surface or openings or plurality or spin or on or material or temperature or "50" or glass or dielectric or etch or etching or plasma or expose or fluid or gas or liquid or region or sparse or dense or trench or photo or resist or coating or cooled or cooling or wafer) | USPAT  | OR       | ON      | 2005/04/26 12:19 |
| L8       | 1    | 1 and (chilled or water or helium or surface or openings or plurality or spin or on or material or temperature or "50" or glass or dielectric or etch or etching or plasma or expose or fluid or gas or liquid or region or sparse or dense or trench or photo or resist or coating or cooled or cooling or wafer) | USPAT  | OR       | ON      | 2005/04/26 12:19 |
| L9       | 431  | 438/9  | USPAT  | OR       | ON      | 2005/04/26 12:45 |
| L10      | 2012 | 438/424  | USPAT  | OR       | ON      | 2005/04/26 12:45 |
| L11      | 759  | 438/427  | USPAT  | OR       | ON      | 2005/04/26 12:45 |
| L12      | 644  | 438/636  | USPAT  | OR       | ON      | 2005/04/26 12:45 |

| L13      | 3113 | 438/637  | USPAT | OR   | ON | 2005/04/26 12:45 |  |
|----------|------|--|-------|------|----|------------------|--|
| L14      | 1469 | 438/700  | USPAT | OR   | ON | 2005/04/26 12:46 |  |
| L15      | 353  | 438/737  | USPAT | OR   | ON | 2005/04/26 12:46 |  |
| L16      | 980  | 438/738  | USPAT | OR   | ON | 2005/04/26 12:46 |  |
| L17      | 517  | 438/704  | USPAT | OR   | ON | 2005/04/26 12:46 |  |
| L18      | 395  | 438/715  | USPAT | OR   | ON | 2005/04/26 12:46 |  |
| S11<br>9 | 0    | (spin adj on adj material) and (plasma adj etching adj process)  | USPAT | OR   | ON | 2005/04/26 11:07 |  |
| S12<br>0 | 0    | (spin adj on adj material)   | USPAT | OR   | ON | 2005/04/26 11:07 |  |
| S12<br>1 | 51   | spin and cool and substrate<br>and(plasma adj etching adj<br>process)  | USPAT | OR   | ON | 2005/04/26 11:08 |  |
| S12<br>2 | 33   | spin and cool and substrate<br>and(plasma adj etching adj<br>process) and surface and opening  | USPAT | OR   | ON | 2005/04/26 11:09 |  |
| S12<br>3 | 8    | spin and cool and substrate<br>and(plasma adj etching adj<br>process) and surface and opening<br>and helium and water  | USPAT | OR · | ON | 2005/04/26 11:10 |  |
| S12<br>4 | 3    | spin and cool and substrate<br>and(plasma adj etching adj<br>process) and surface and opening<br>and helium and (chilled adj water)  | USPAT | OR   | ON | 2005/04/26 12:45 |  |
| S12<br>5 |      | S123 and (chilled or water or helium or surface or openings or plurlity or spin or on or material or temperature or "50" or glass or dielectric or etch or etching or plasma or expose or fluid or gas or liquid or region or sparse or dense or trench or photo or esist) | USPAT | OR   | ON | 2005/04/26 12:08 |  |